

## 2017 Editorial Calendar

(Editorial close date: 4/21)	July • August	* indicates show distribution
FOWLP		• ICEPT 2017 • Harbin, China (Aug 16-19)
WLP surface processing		• SEMICON Taiwan * Taipei, Taiwan (Sept 13-15)
Wafer probing		• BiTS China 2017 TBD, China (TBD)
CSP hermetic packaging		<ul> <li>European MEMS Summit Grenoble, France (Sept 20-22)</li> </ul>
TSV technologies		
Die attach solutions		
3D metrology challenges		
HVM challenges of die bonding		

Ad Space Close Jun 24 - Ad Materials Close Jul 1

(Editorial close date: 6/9)	September • October	* indicates show distribution	
FOWLP & panel-level processes update		• IMAPS 2017 * Raleigh, NC, CA (Oct 9-12) • IWLPC-International Wafer-Level Packaging Conference & Exhibition * San Jose, CA (Oct 24-26) • International Test Conference (ITC) Fort Worth, TX (Oct 31- Nov 2) • MEMS Executive Congress	
Consortia collaboration			
Packaging ICs/sensors for automotive applications			
Advanced interconnects			
Thermal interface materials		Napa Valley, CA (Nov 1-2)  • SEMICON Europa  Munich, Germany (Nov 14-17)	
Final test			
Packaging SiPs/SiP supply chain			
Chip / package interaction			
Advanced embedded packaging for power devices			

Ad Space Close Sep 9 - Ad Materials Close Sep 16

(Editorial close date: 9/1)	November • December	* indicates show distribution
2.5D & 3D ICs		• SEMICON Japan
Stacked die CSPs		Tokyo, Japan (Dec 13-15)  • 3D ASIP Conference *  Burlingame, CA (TBD)
China market update		• SEMI European 3D Summit * Grenoble, France (TBD)
Dicing & singulation		
Silicon Photonics update		
Thermal management of ICs		
Thermocompression bonding		
IC cleaning process		

Ad Space Close Nov 4 - Materials Close Nov 11